



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: M. HATANO, et al.
Application No.: 10/670,356
Filed: September 26, 2003
For: THIN FILM SEMICONDUCTOR DEVICE,
POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
PRODUCTION PROCESS AND PRODUCTION APPARATUS
Art Unit: 2813
Examiner: T. NGUYEN

AMENDMENT

MS: AMENDMENTS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 19, 2005

Sir:

In response to the Office Action dated April 18, 2005, the period of response for which extension of time is requested in the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the Amendments; and

An Appendix follows the Amendments including a Sketch.